

International Application No.: PCT/JP2004/018051

U.S. Patent Application No.: Unknown

May 2, 2006

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AMENDMENTS TO THE SPECIFICATION:

A substitute specification and a marked-up copy of the English translation of the originally filed PCT application are attached hereto.

Please replace the Title of the Invention originally filed with the above-identified patent application with the following new Title:

TRANSISTOR AND CVD APPARATUS USED TO DEPOSIT GATE
INSULATING FILM THEREOF